IFW





MAIL STOP AF PATENT 8043-1004

April 21, 2004

## IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Katsuhisa YUDA

Serial No. 09/729,193

Filed December 5, 2000

PLASMA CVD APPARATUS COMPRISING A PLASMA CONFINING ELECTRODE

Conf. 6697

Group 1763

Examiner M. Alejandro

## RESPONSE AFTER FINAL REJECTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Official Action mailed February 3, 2004, applicant responds as follows:

A Listing of the Claims begins on page 2 of this paper.

Remarks begin on page 7 of this paper.